APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention

SYSTEM AND METHOD TO REDUCE ARTIFACTS AND IMPROVE COVERAGE IN MR SPECTROSCOPY

Application Type : regular, utility
Attorney Docket Number : GEMS8081.159

Correspondence address:

Customer Number: 27061

Inventors Information:

Inventor 1:

Applicant Authority Type: Inventor Citizenship: TR
Given Name: C.
Middle Name: Celil

Family Name: Residence:

City of Residence: Waukesha

State of Residence: WI
Country of Residence: US

Address-1 of Mailing Address: 1600 Lindsay Way

Guclu

Address-2 of Mailing Address:

City of Mailing Address: Waukesha

State of Mailing Address:

Postal Code of Mailing Address:

Country of Mailing Address: US

Phone: Fax:

E-mail:

Inventor 2:

Applicant Authority Type: Inventor
Citizenship: MX
Given Name: Ricardo
Family Name: Becerra

Residence:	
City of Residence:	Waukesha
State of Residence:	WI
Country of Residence:	US
Address-1 of Mailing Address:	2124 Grayfox CT.
Address-2 of Mailing Address:	
City of Mailing Address:	Waukesha
State of Mailing Address:	
Postal Code of Mailing Address:	
Country of Mailing Address:	US
Phone:	
Fax:	
E-mail:	
Inventor 3:	
Applicant Authority Type:	Inventor
Citizenship:	MX
Given Name:	Eduardo
Family Name:	Figueiredo
Residence:	
City of Residence:	Sao Paulo
Country of Residence:	BR
Address-1 of Mailing Address:	Tr. Francisco Doria de Andrade, 52
Address-2 of Mailing Address:	
City of Mailing Address:	Sao Paulo
State of Mailing Address:	
Postal Code of Mailing Address:	
Country of Mailing Address:	BR
Phone:	
Fax:	
E-mail:	
Attorney Information:	
•	
practitioner(s) at Customer Number:	

27061

as our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.